

INFORMATION DISCLOSURE CITATION*(Use several sheets if necessary)*

Docket number (Optional)

15689.49.3

Application Number

10/673,784

Applicant(s)

Takehiro Nakamura et al.

Filing Date

September 29, 2003

Group Art Unit

2618

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

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FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
	1	0 682 418 A2	05/12/1995	EPO	H0487	005	X	
	2	CN1126930	7/17/1996	China	H04B7	005	X	

EXAMINER

DATE CONSIDERED

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*Examiner Initial	OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
	3	Chinese Office Action for Chinese Patent Application No.: 20031010330.1
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